



ELECTRONIC COPY

LG636408541
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT

May 31, 2024
IGI Report Number **LG636408541**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **8.38 X 5.73 X 3.84 MM**

GRADING RESULTS

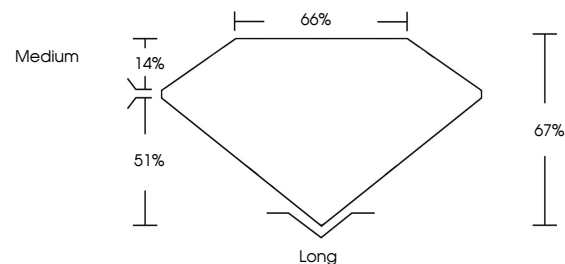
Carat Weight **1.81 CARAT**
Color Grade **E**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG636408541**

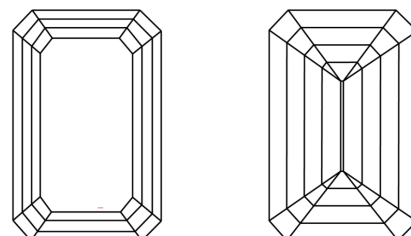
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

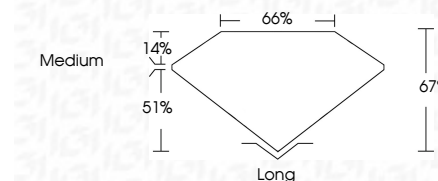
D E F G H I J Faint Very Light Light

CLARITY

| | | | | |
|---------------------|-----------------------------|------------------------|-------------------|------------------|
| IF | VS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
| Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI

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IGI Report No. **LG636408541**
EMERALD CUT
8.38 X 5.73 X 3.84 MM
Carat Weight **1.81 CARAT**
Color Grade **E**
Clarity Grade **VS 1**
Depth **67%**
Table **66%**
Girdle **Medium**
Culet **Long**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG636408541**

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